FORM PTO-1449 (REV.7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			DOCKET NO. ION402		APPLICATION NO. Unknown		
INI	FORM	ATION DISCLOSU	RE STATEMEN	г	APPLICANTS: Adi Scheidemann, Mark McGraw, and				
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				TENT	DOCUMENTS			r	
•EXAMINE R INITIAL		DOCUMENT NUMBER	DATE		NAME	CLAS	SUBCLASS	FILING IF APPRO	DATE OPRIATE
len		U.S. 5,317,151	05-1994	Sinha	Sinha et al.		298		
		U.S. 5,801,380	09-1998	Sinha		250	299		
	U.S. 6,046,451		04-2000	Sinha	Sinha		298		
	U.S. 6,182,831 B1		02-2001	Schei	Scheidemann et al.		213		
		U.S. 6,191,419 B1	02-2001	Sinha	1	250	294		
		U.S. 6,403,956 B1	06-2002	Sinha	1	250	298		
lew	U.S. 6,576,899 B2		06-2003	Sinha	Sinha et al.		299		
								<u> </u>	
			FOREIGN	I PATE	NT DOCUMENTS				
	DOCUMENT		DATE	,	COUNTRY	CLAS	SUBCLASS	TRANS	LATION
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					Author, Title, Date, Pertinen	,	1040	·	
EN		J. Mattauch, Er	gebnisse der exakt	en Natur	vissenschaften, vol 19, p	age 1/0-236	, 1940		
		Robert B. Darling, Adi A. Scheidemann, K. N. Bhat, and TC. Chen, Micromachined Faraday Cup Array Using Deep Reactive Ion Etching, Sensors and Actuators, A95 (2002) 84-93							
		R. B. Darling, A. A. Scheidemann, K. N. Bhat, and TC. Chen,, Proc. of the 14th IEEE Int. Conf. on Micro Electro Mechanical Systems (MEMS-2001), Interlaken, Switzerland, Jan. 21-25, 2001, pp. 90-93							
	Nier, D. J. Schlutter Rev. Sci. Instrum. 56(2), page 214-219, 1985								
	-	T W Burgovn	e et al I Am Soc	Mass Si	pectrum 8, page 307-318	1997	· · · · · · · · · · · · · · · · · · ·		
len		1 bango)	o o u o .	ass 01	oonam o, page ser see	,			
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